

MAIL STOP AMENDMENT
PATENT
8075-1099

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Yasuhiko KASAMA et al. Conf. 9603

Application No. 10/585,245 Group 1792

Filed January 10, 2007 Examiner M. Padgett

ION IMPLANTATION METHOD AND ION IMPLANTATION APPARATUS

AMENDMENT

Assistant Commissioner for Patents August 31, 2010
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the **non-final** Office Action of March 31, 2010, a period for reply which has been extended two months.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 8 of this paper.